

<b>Notice of References Cited</b>		Application/Control No. 10/799,307	Applicant(s)/Patent Under Reexamination KIM ET AL.	
		Examiner LUCY P. CHIEN	Art Unit 2871	Page 1 of 1

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*	B	US-6,922,219	07-2005	Jin et al.	349/113
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	K	US-			
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**NON-PATENT DOCUMENTS**

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